

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Toru YAMADA

Application No.: 10/582,802

Filed: June 14, 2006

For: VAPOR PHASE GROWTH APPARATUS AND MAIL STOP RCE  
METHOD OF FABRICATING EPITAXIAL  
WAFER



Group Art Unit: 1714

Examiner: M. SONG

Docket No.: 136170

**LARGE ENTITY REQUEST FOR  
CONTINUED EXAMINATION UNDER 37 C.F.R. §1.114**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. §1.114, Applicant(s) hereby request(s) continued examination.

☒ Applicant(s) further request(s) entry and consideration of the submission filed April 11, 2011.

The above-identified application was filed on or after June 8, 1995. Thus, entry is proper under 37 C.F.R. §1.114(d).

Attached hereto is our check no. 237089 in the amount of ☒ \$810.00 as payment of the fees set forth in 37 C.F.R. §1.17(e). The Commissioner is hereby authorized to charge any additional fees or credit any overpayment associated for this filing to Deposit Account No. 15-0461.

Respectfully submitted,

William P. Berridge  
Registration No. 30,024

Aya Suzuki  
Registration No. 64,621

WPB:AQS/sxl

Date: April 28, 2011

**OLIFF & BERRIDGE, PLC**  
**P.O. Box 320850**  
**Alexandria, Virginia 22320-4850**  
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<p><b>DEPOSIT ACCOUNT USE AUTHORIZATION</b> Please grant any extension necessary for entry of this filing; Charge any fee due to our Deposit Account No. 15-0461</p>
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04/29/2011 AWONDAF1 00000087 10582802

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